



Non-contact 3D Measuring System QUICK VISION WLI Pro Series



Catalog No.E14001(4)

Non-contact 2D Measurement and 3D Shape Measurement in a Single System

Advanced High Precision Dual Head Measuring System equipped with White Light Interferometer (WLI) Optical Head

Non-contact 2D/3D measurement with high precision and high resolution

White light interferometer (WLI optical head) applied to vision measuring systems enables a wide range of powerful measurements, from 2D measurement of coordinates and dimensions, surface analysis in microscopic areas, depth measurement of small-diameter holes, and to high-precision 3D measurement of wiring dimensions on a printed circuit board.



Capable of measuring a wide variety of surfaces

In addition to online programming using 3D CAD models, an offline program can be created from an image or with a touch probe. This makes it possible to increase up-time of the QUICK VISION Pro main unit, thereby shortening production lead times.



Principle of WLI measurement

A white light is split into two beams, one for the reference mirror within the interference objective lens and the other for the measurement sample. When the interference objective lens is swept in the Z-direction, white interference fringes are generated only in the area of the measurement sample that is focused. The three dimensional shape of the object being measured is calculated by detecting the peak position of the interference fringe intensity at each pixel position of the CCD camera.







PERFORMANCE

Top Performance Presented by Continuously Evolving Vision Measuring Function and Advanced WLI Optical Head

High-efficiency measurement achieved by a single machine performing two roles

WL

Coordinate dimension measurement has inherited all of the proven vision measuring functions of Quick Vision Pro.

Switches to 3D measurements without setup changes following vision measurement.

Seamlessly continuous measurement is made possible by Quick Vision Pro's automatic control.

Vision optical head coordinates, pitch, diameter, width, angle, etc. WLI optical head (3D measurement) surface analysis, cross-sectional dimensions, steps, contour matching, etc.

Easy targeting of measurement position

Offset amount of vision optical head and WLI optical head is calibrated with high accuracy.

Switching to high-magnification WLI optical head after positioning with vision optical head of low magnification and a wide field of view does not lose sight of the targeted area, thus guaranteeing a highly efficient measurement.



Advanced-design platform culminating from Mitutoyo's high accuracy technology

Main frame structure boasting a large stage and high accuracy is achieved by structure having a fixed bridge and a translation stage providing mutually independent X-axis and Y-axis movements, which are advantageous for achieving high accuracy.

For added stability of measurement, a pneumatic auto-leveling vibration isolator is provided as a standard structure.

Unique design principle of Quick Vision WLI Pro series guarantees superb vibration isolation performance.

Achieves high precision measurement for a wide range of applications, from long dimensions of large workpieces to minute dimensions.



APPLICATION

Semiconductor package substrate



Surface analysis

Semiconductor package substrate



ID and depth measurements

Board-to-Board connector



Cross-sectional shape measurement

Microscopic precision machined part



Cross-sectional shape measurement

Semiconductor package substrate



Cross-sectional shape measurement

Metal thin film



Surface analysis, and step measurement

Board-to-Board connector



Coordinate-position, OD, and height measurements

3D Surface Texture Analysis



Surface analysis, step, and cross sectional measurements

SOFTWARE



QVPAK

A function for acquiring interference fringes is added to QVPAK Software having high functionality and universal application capabilities for vision measuring systems. The measurement procedure program prepared by QVPAK automatically controls the coordinates and dimensions in vision measurement, 3D data synthesis in WLI measurement, data output, and shape/evaluation analysis software (optional) thus providing a highly efficient measurement system.

Examples of computational capabilities



Versatile vision measurement



Circular tool



Al illumination tool (automatic compensation of light)





Multi point AF



Auto trace tool



Various filters



Pattern search tool



Geometric deviation drawing

QV3D Function (optional)

Synthesizes three dimensional shape data from interference fringes to display shapes or outputs point cloud data to external sources. Point cloud data can be used for generating surfaces, as well as for outputting height, and internal/outer diameter. Also, 3D data can be transferred to the shape/evaluation analysis software (optional) to implement shape measurement and surface analysis.

Applications

Enables you to switch from inaccurate visual inspections to accurate measurements based on automatic computation.



3D Profile Stitching

This function allows concatenation of multiple fields of 3D profile data unless only single field measurement can cover an object area to be measured. The running of 3D profile stitching enables a wide range of measurement or analysis while maintaining a high resolution.



MSURF-I

Conducts analysis or comparison verification of measured point cloud data through QVH1 Pro/QVH4 Pro and QV WLI Pro in reference to nominal data (supporting CAD data import). Note: A separate PC is necessary for MSURF-I analysis.



OPTIONAL SOFTWARE

FORMTRACEPAK-AP

Form Evaluation and Analysis Software

Contour Tolerancing Function

\cdot Design data creation

CAD data conversion, master workpiece conversion, function specification, text file conversion, and aspherical surface design value creation

- · Tolerancing
- Normal vector direction tolerancing, axial direction tolerancing, and bestfit tolerancing
- · Result display

Result listing, error graph, error developed view, error coordinate value display function, analysis result display

Microscopic Form Analysis

· Analyzed items: point measurement, line measurement, circle measurement, distance measurement, intersection measurement, angle measurement, origin setting, and axial rotation

 \cdot Calculated items: maximum, minimum, average, standard deviation, and area

Report Creation Function

· Measurement result, error graph, and error developed view

Other Functions

- \cdot Recording and executing analysis
- procedures
- External output function: CSV, text or DXF/IGES format output
- · Fairing process
- \cdot Quadratic curve fitting function
- · Quasi-roughness analysis function







MCubeMap

3D Surface Property Analyzing Software

Clear and informative imaging of analyzed data using powerful graphics technology.

The software conforms to the latest ISO25178-2 3D Surface Texture Parameter Specifications, allowing analysis of parameters such as height of Sa, Sq, etc., space, compound and volume.

The user can easily create a graphical report where analysis results are freely laid out.



Other optional software programs for Quick Vision are also available. For detailed information, refer to the Quick Vision Pro series catalog.

Abundant Data Manipulation and Analysis Functions

This function handles leveling, outlier processing, formelimination, bearing area curve, peak distribution, twist analysis, hole/protrusion volume, texture orientation, and others.

OPTIONS

QV Objectives

Objective		QV-SL0.5x*1	QV-HR1x	QV-SL1x	QV-HR2.5x	QV-SL2.5x	QV-HR5x	QV-5x	QV-HR10x*1	QV-10x*1	QV-25x*1
Code No.		02AKT199	02AKT250	02ALA150	02AKT300	02ALA170	02AWD010	02ALA420	02AKT650	02ALG010	02ALG020
Set of objectives that support PFF		-	-	-	02AKX895B	-	02AXA915B	02AKX900B	02AKX905B	-	02AKX910B
Working distance [mm]		30.5	40.6	52.5	40.6	60.0	20.0	33.5	20.0	30.5	13.0
Field of view [mm]* ² (H)×(V)	Turret 1x	12.54x9.4	6.27x4.7		2.49x1.86		1.24x0.93		0.62x0.47		0.25x0.18
	Turret 2x	6.27x4.7	3.13x2.35		1.24x0.93		0.62x0.47		0.31x0.23		0.12x0.09
	Turret 6x	2.09x1.56	1.04x0.78		0.41x0.31		0.20x0.15		0.10x0.07		0.04x0.03
	Digital magnificationq 12x	1.04x0.78	0.52x0.39		0.20x0.15		0.10x0.07		0.05x0.03		0.02x0.01

*1 When the QV-SL0.5x, QV-HR10x, QV-10x, or QV-25x objective is used, some limitations, such as the illumination being insufficient depending on the workpiece, may occur. *2 The values for field of view are not guaranteed values, but representative values.

WLI interference objective lens



Collision detection unit



It is a collision prevention sensor equipped with QVWLI.

It is available for QVWLI A-25x and QVWLI A-50x. The collision prevention sensor contacts stages or workpieces to stop the movement of the Z-axis to prevent the WLI interference objective lens from damage.

Field of Operating Interference Monitor **Objective Lens** Code No. View* Distance Method Magnification (mm) (mm) QVWLI A-5x 02ALY400 Mirror 270x 0.64 x 0.48 13.2 **QVWLI A-10x** 02ALT630 Mirror 540x 0.32 x 0.24 12.6 QVWLI A-25x 02ALT670 Mirror 1350x 0.13 x 0.10 4.7 QVWLI A-50x 02AWB150 Mirror 2700x 0.064 x 0.048 2.4

Monitor magnification shown here is that of Size 24 Liquid Crystal Display (resolution WUXGA). *1 Tube lens 2x is provided as a standard equipment. Also, The values for field of view and monitor magnification are not guaranteed values, but representative values.

Calibration

Tilt compensation jig for WLI optical head

Enables to compensate the mounting posture of WLI optical head. It helps to achieve measurement of the highest accuracy by compensating the tilting error of WLI optical head.



Calibration chart

A calibration chart is used to compensate for the pixel size of the camera imaging chip and for the auto focus accuracy and optical axis offset at each magnification of the variable magnification unit (PPT).



Interference fringe adjustment jig

Enables to adjust the focusing position of WLI interference objective lens with the position where interference fringes occur.

It is used in combination with the calibration chart.



QV compensation chart

This glass chart is used to perform compensation for distortions within the screen caused by the optical system, and auto focus compensation, which reduces auto focus variations that are caused by differences between the workpiece pattern and texture.

Note: There are limitations on the function, depending on the lens. For details, contact your Mitutoyo sales office.



Interference adjustment jig

Calibration chart

LINE-UP



QVWLI HYPER 404 Pro



QVWLI HYPER 606 Pro

Specifications

Model name			QVWLI HYPER 404 Pro	QVWLI HYPER 606 Pro					
Model code			QVW-H404P1L-E	QVW-H606P1L-E					
Main unit									
Measuring range (X×Y×Z) [mm]			400×400×240 600×650×220						
Measuring range common to vision and WLI (X×Y×Z) [mm]			315×400×240	515×650×220					
External dimensions (W×D×H) (Including vibration isolator) [mm]			1118×1426×1781	1400×1994×1794					
Stage glass (W×D) [mm]			493×551	697×758					
Main unit mass (Including vibration isolator) [kg]			1205	2275					
Vision measuring accuracy [µm]*1	Vision	Eux / Euy, mpe	(0.8 + 2L / 1000)						
		EUXY, MPE	(1.4 + 3L / 1000)						
		Euz, mpe	(1.5 + 2L / 1000)						
	STREAM* ² (optional)	E1x, E1y	(1.5 + 3L / 1000)						
		E2XY	(2.0 + 4L / 1000)						
	Optical magnification		2.5x objective (QV-HR2.5x or QV-SL2.5x) and middle magnification tube lens						
WLI repeatability [µm]* ²			2 σ≤ 0.08						
Resolution of scale [µm]			0.01						
Accuracy guaranteed environment	Ambient temperature		20±1 °C						
	Temperature variation		0.5 °C/1H and 1 °C/24H						
	Acoustic condition		70 dB or less						
Maximum stage loading [kg]* ³			25	35					
Observation unit	Image caprutin	g Vision	B&W CMOS digital camera						
	device	WLI	CCD c	amera					
	Power turret*4		Programmable power turret 1x, 2x, 6x, (12x)*5						
Illumination unit	Stage light		White LED						
	Vertical coaxial light (Vision)		White LED						
	Vertical coaxial light (WLI)		Halogen						
	PRL		White LED						
Air supply	Pressure		0.4 N	0.4 MPa*6					

*1 L: arbitrary measuring length (unit: mm) *2 Determined by Mitutoyo's inspection method. *3 An excessively biased or concentrated load is excluded. *4 Programmable power turret 1x, 2x, 4x, 6x model is available by special order. Digital magnification function allows 8x and 12x in addition to 1x, 2x, 4x, 6x. 6 steps of magnification are available in total. *5 The value in parenthesis is for digital magnification change. *6 Air supply pressure to be in range 0.45 to 0.7 MPa.

Dimensions

QVWLI HYPER 404 Pro

unit: mm



QVWLI HYPER 606 Pro





Whatever your challenges are, Mitutoyo supports you from start to finish.

Mitutoyo is not only a manufacturer of top quality measuring products but one that also offers qualified support for the lifetime of the equipment, backed up by comprehensive services that ensure your staff can make the very best use of the investment.

Apart from the basics of calibration and repair, Mitutoyo offers product and metrology training, as well as IT support for the sophisticated software used in modern measuring technology. We can also design, build, test and deliver measuring solutions and even, if deemed cost-effective, take your critical measurement challenges in-house on a sub-contract basis.



Find additional product literature and our product catalogue

https://www.mitutoyo.co.jp/global.html

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Do not commit an act, which could directly or indirectly, violate any law or regulation of Japan, your country or any other international treaty, relating to the export or re-export of any commodities.

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